



Attorney Docket No.:SAM-0526  
Application Serial No.: 10/796,507  
Reply to Office Action of: June 13, 2006

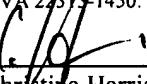
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al* Examiner: El Arini, Zeinab  
Serial No.: 10/796,507 Group Art Unit: 1746  
Filing Date: March 9, 2004  
Title: METHOD OF RINSING AND DRYING SEMICONDUCTOR  
SUBSTRATES (As Amended)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10/11/06  
Date

  
Christina Harris

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT C

Sir:

The following is in response to the Office Action dated June 13, 2006. A petition for a one-month extension of the time period in which to respond is filed concurrently herewith.  
Please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.